

Attorney Docket No.: 033082M300



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Confirmation No.: 1005

Applicants : Yasuo KOBAYASHI, et al.  
U.S. Serial No. : 10/568,461  
Filed : February 15, 2006  
Examiner : Reema PATEL  
Group Art Unit : 2812  
For : SEMICONDUCTOR DEVICE, METHOD FOR  
MANUFACTURING SEMICONDUCTOR DEVICE  
AND GAS FOR PLASMA CVD

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed on March 30, 2007, please amend the above-identified application as set forth below and consider the following remarks.

This Amendment is accompanied by a Petition for Extension of Time (Three Months) and a deposit account payment for the sum of \$1170, in payment of the extension fee (\$1020) and for the addition of three dependent claims (\$150).

10/01/2007 JADD01 00000005 024300 10568461  
02 FC:1202 150.00 DA